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PATENT
03345-P0041A WWW/DWA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	Piotr Strzyzewski
Serial No. 10/601,508	Filing Date: June 23, 2003
Title of Application:	Method And Device For Treating Semiconductor Substrates
Confirmation No. 9726	Art Unit: 2829
Examiner	Monica D. Harrison


Mail Stop Non-Fee Amendment
Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Response to Official Action

In response to the Official Action of August 24, 2004, Applicant submits the following Remarks. Applicant believes that no fee is due in connection with the filing of this Response. However, if any fee is due, please charge Deposit Account No. 19-4516.

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1450; Alexandria, VA 22313-1450.

November 22, 2004


Paul Bosley